

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination
	09/920,275/01773,879	CHRYSLER ET AL.
Examiner	Art Unit	
Scott B. Geyer	2829 2818	Page 1 of 1

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✓	B	US-5,650,639	07-1997	Schrantz et al.	257/77
	C	US-			
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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
✓	U	Liu et al., "DIAMOND CHEMICAL VAPOR DEPOSITION: Nucleation and Early Growth Stages", 1995, pages 1-7.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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12/12/04

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	I	US-			
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	K	US-			
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Dan S. Geyer 12/12/04